

Thin Film Coating Facility

Tender No: CSIO/2023-24/TFCF/LPC/07

Date: 29th November, 2023

Sub: Regarding in extension in date of Tender Submission and Corrigendum related to Specification of required item

This is regarding the tender enquiry no. as mentioned above. The specifications of the required item may be read as below:

Sputtering Coating Target – W doped VO₂, V_(1-x)W_xO₂, **x = 0.02**, 6 inch Dia x 3 mm Thick + Cu 3 mm Thick, Purity 3N or better

The due date for submission of bids is hereby extended as below:

Due date of Bid Submission: **04.12.2023, 2:00 PM**

Due date of Opening of Bids: **04.12.2023, 3:00 PM**



(Dr. Mukesh Kumar)
For & on behalf of CSIR-CSIO